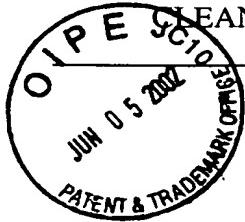


6P1765
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Attorney Docket No. LAM1P109
Julia S. SVIRCHEVSKI et al.) Examiner: L. Umez-Eronini
Application No. 09/336,401) Group Art Unit: 1765
Filed: June 18, 1999 (CPA filed 11/27/2001)) Date: May 20, 2002
For: POST-PLASMA PROCESSING WAFER)
CLEANING METHOD AND SYSTEM)



Commissioner for Patents
Washington, DC 20231

Sir:

Applicants transmit herewith an amendment in the above-identified application.

The fee has been calculated as shown below.

	<u>Claims Remaining After Amendment</u>	<u>Highest Previously Paid For</u>	<u>Present Extra</u>	<u>SMALL ENTITY RATE FEE</u>	<u>OR</u>	<u>LARGE ENTITY RATE FEE</u>
TOTAL CLAIMS	<u>22</u>	<u>-</u>	<u>22</u>	<u>00</u>	X09 = \$	OR
INDEP CLÁIMS	<u>03</u>	<u>-</u>	<u>03</u>	<u>00</u>	X42 = \$	OR
			TOTAL	\$ _____		\$0



Applicants hereby petition for a two-month extension of time to respond to the Office Action. Applicants believe that no additional Extension of Time is required; however, if it is determined that such an extension is required, Applicants hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM1P109).



Enclosed is our Check No. 6955 in the amount of \$400.00 to cover the extension of time fee. If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, then please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM1P109). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE & PENILLA, LLP

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